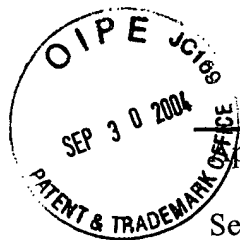


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant(s): **SATOH, Yoshihiro**

Serial No.: **09/981,402**

Filed: **October 17, 2001**

Title: **Semiconductor Device and Method  
for Its Manufacture**

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Group Art Unit: **2815**

Examiner: **Richards, N. D.**

**AMENDMENT AFTER FINAL ACTION  
(37 C.F.R. §1.116)**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated June 2, 2004, and is currently due October 4, 2004 with a 1-month extension.

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37 C.F.R. §1.8

15 I hereby certify that this correspondence is being

[ ] transmitted via facsimile to the United States Patent and Trademark Office to fax number: \_\_\_\_\_  
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20 [X] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

Date of Deposit: September 27, 2004

25 Typed/Printed Name: Darryl Walker

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